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Sheet _ 1 (A) of 1 SUBSTITUTE FORM PTO-1449 U.S. DEPARTMENT OF COMMERCE ATTY. DOCKET NO. SERIAL NO. PATENT AND TRADEMARK OFFICE **TPS-012** Express Mail Label No. (MODIFIED) EV296622163US INFORMATION DISCLOSURE **APPLICANT** Raymond Joe et al. STATEMENT BY APPLICANT **FILING DATE GROUP** (Use several sheets if necessary) March 31, 2004 Unknown (37 CFR 1.98(b)) **U.S. PATENT DOCUMENTS** FILING DATE ISSUE **EXAMINER** IF APPROPRIATE PATENT NUMBER **PATENTEE** CLASS **SUBCLASS** INITIAL DATE 9 lo 7 07/18/2000 438 01/20/1998 6 0 0 5 677 A.A Arena et al. A.B A.C A.D A.E A.F A.G A.H A.I A.J A.K FOREIGN PATENTS OR PUBLISHED FOREIGN PATENT APPLICATIONS DOCUMENT **PUBLICATION COUNTRY OR TRANSLATION SUBCLASS** NUMBER DATE PATENT OFFICE **CLASS** (YES/NO) A.L A.M A.N A.O A.P A.Q OTHER DOCUMENTS (Including Author, Title, Date, Place of Publication) Chang et al., Low Contamination Plasma Chamber Components and Methods for Making the Same, US 2002/0086118 A1, A.R Publication Date 7/04/2002, filed 12/29/2000, U.S. Class 427/447. A.S A.T **EXAMINER** DATE CONSIDERED /Bret Chen/ 05/30/2008

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